Special Issue

Computer Vision Sensing and Pattern Recognition

Message from the Guest Editor

This Special Issue is devoted to computer vision and pattern recognition methods based on deep learning (CVPR-DL). we invite submissions related to, but not limited to, the following research topics: vision research under new imaging conditions, biologically inspired computer vision research, multi-sensor fusion 3D vision research, visual scene understanding under highly dynamic complex scenes, small-sample target recognition and understanding, and complex behavior semantic understanding. Theoretical and experimental studies are welcome, as are comprehensive review and survey papers.

Guest Editor

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Deadline for manuscript submissions

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developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. Sensors organizes Special Issues devoted to specific sensing areas and applications each year.

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